



INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)		Attorney Docket No.: 46884-5461	Serial No.: 10/571,142
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*Examiner Initial	Document Number	Date	Name	Class	Sub Class	Filing Date
	2004/0002199	Jan. 1, 2004	Fukuyo et al.	-	-	
	6,992,026	Jan. 31, 2006	Fukuyo et al.	-	-	
	2006/0148212	July 6, 2006	Fukuyo et al.	-	-	
	3,610,871	Oct. 5, 1971	Lumley	-	-	
	3,626,141	Dec. 7, 1971	Daly	-	-	
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	3,790,051	Feb. 5, 1974	Moore	-	-	
	4,242,152	Dec. 30, 1980	Stone	-	-	
	4,531,060	Jul. 23, 1985	Suwa et al.	-	-	
	5,230,184	Jul. 27, 1993	Bukhman	-	-	
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	5,925,271	Jul. 20, 1999	Pollack et al.	-	-	
	5,968,382	Oct. 19, 1999	Matsumoto et al.	-	-	
	5,976,392	Nov. 2, 1999	Chen	-	-	
	6,031,201	Feb. 29, 2000	Amako et al.	-	-	
	6,175,096	Jan. 16, 2001	Nielsen	-	-	
	6,181,728	Jan. 30, 2001	Cordingley et al.	-	-	
	6,285,002	Sep. 4, 2001	Ngoi et al.	-	-	
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	WO 02/22301 A1	March 21, 2002	PCT			Abstract	
	165354	Aug. 1, 1991	Taiwan			Abstract	
	192484	Oct. 11, 1992	Taiwan			Abstract	
	219906	Feb. 1, 1994	Taiwan			Abstract	
	WO 2004/082006	Sep. 23, 2004	PCT			Abstract	
	0 863 231	Sep. 9, 1998	Europe				
	2001-017690	Mar. 5, 2001	Korea			Abstract	
	59-130438	Jul. 27, 1984	Japan			Abstract	
	60-144985	Jul. 31, 1985	Japan			Abstract	
	62-004341	Jan. 10, 1987	Japan			Abstract	
	64-038209	Feb. 8, 1989	Japan			Abstract	
	03-276662	Dec. 6, 1991	Japan			Abstract	

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	5,656,186	August 12, 1997	Mourou et al.	-	-	
	5,543,365	August 6, 1996	Wills et al.	-	-	
	2004/0002199 A1	January 1, 2004	Fukuyo et al.	-	-	
	5,211,805	May 18, 1993	Srinivasan	-	-	

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	04-029352	Jan. 31, 1992	Japan			Abstract		
	04-300084	Oct. 23, 1992	Japan			Abstract		
	08-197271	Aug. 6, 1996	Japan			Abstract		
	09-260310	Oct. 3, 1997	Japan			Abstract		
	10-071483	Mar. 17, 1998	Japan			Abstract		
	10-214997	Aug. 11, 1998	Japan			Abstract		
	10-233373	Sep. 2, 1998	Japan			Abstract		
	11-071124	Mar. 16, 1999	Japan			Abstract		
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	2000-210785	Aug. 2, 2000	Japan			Abstract		
	2000-237885	Sep. 5, 2000	Japan			Abstract		
	2000-237886	Sep. 5, 2000	Japan			Abstract		
	2001-127015	May 11, 2001	Japan			Abstract		
	2001-326194	Nov. 22, 2001	Japan			Abstract		
	2002-192368	Jul. 10, 2002	Japan			Abstract		
	2002-205181	Jul. 23, 2002	Japan			Abstract		
	2002-224878	Aug. 13, 2002	Japan			Abstract		
	2005-047290	Feb. 24, 2005	Japan			Abstract		
	2005-313237	Nov. 10, 2005	Japan			Abstract		
	JP 8-264488	Oct. 11, 1996	Japan			Abstract		
	JP 9-017831	Jan. 17, 1997	Japan			Abstract		
	JP 11-121517	Apr. 30, 1999	Japan			Abstract		
	WO 03/076118	Sep. 18, 2003	Japan			Abstract		

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	A. Ishii et al., CO2 Laser Processing Technology, Nikkan Kogyo Publishing Production, Dec. 21, 1992, pp. 63-65 (with partial English translation)
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		JP 4-188847	July 7, 1992	Japan			Abstract
		JP 7-263382	October 13, 1995	Japan			Abstract
		JP 9-263734	October 7, 1997	Japan			Abstract
		JP 2006-128723	May 18, 2006	Japan			Abstract
		JP 2002-192367	July 10, 2002	Japan			Abstract
		JP 2000-042764	February 15, 2000	Japan			Abstract
		JP 5-335726	December 17, 1993	Japan			Abstract
		11-162889	June 18, 1999	Japan			Abstract
		61-121453	Sept. 6, 1986	Japan			Abstract
		2005-001001	Jan. 6, 2005	Japan			Abstract
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		WO 02/07927 A1	January 31, 2002	PCT			
		10-305420	November 17, 1998	JP			Abstract
		04-111800	April 13, 1992	JP			Abstract
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		07-037840	February 7, 1995	JP			Abstract
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	46-24989 (corresponding to U.S. 3,629,545)	July 19, 1971	JP					

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(Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.)

	"New Laser Handbook" published by Asakusa Shoten, June 15, 1989, pp. 666-669, including English language translation
	Tooling Machine Series, "Laser Machining" published by Taiga Shuppan Inc., 1990, pp. 91-96, including English language translation
	"Stealth Dicing, It's Principles and Features: A Technology Most Suitable for Dicing Very Thin Semiconductor Wafers" published by Takaoka Hidetsugu, Electronic Material No. 9, 2002, pp. 17-21, including English language translation
	Journal of the Japan Society of Griding Engineers, Vol. 47, No. 5, May (2003), pp. 229-231, including English language translation
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